



ELECTRONIC COPY

LG669476820
Report verification at igi.org



December 26, 2024

IGI Report Number **LG669476820**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **OVAL BRILLIANT**

Measurements **7.87 X 5.74 X 3.60 MM**

GRADING RESULTS

Carat Weight **1.02 CARAT**

Color Grade **G**

Clarity Grade **VS 1**

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ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

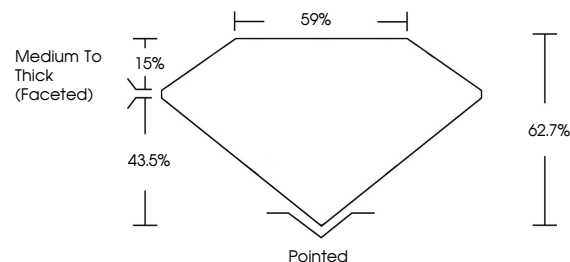
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG669476820**

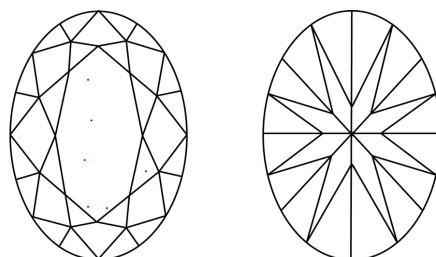
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

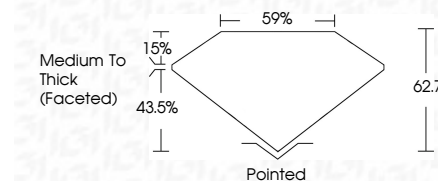
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| | | | | |
|---------------------|-----------------------------|------------------------|-------------------|------------------|
| IF | VS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
| Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



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Symmetry **EXCELLENT**

Fluorescence **NONE**

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IGI



December 26, 2024
IGI Report No LG669476820
OVAL BRILLIANT
7.87 X 5.74 X 3.60 MM
Carat Weight **1.02 CARAT**
Color Grade **G**
Clarity Grade **VS 1**
Depth **62.7%**
Table **59%**
Girdle **Medium To Thick (Faceted)**
Culet **Pointed**
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG669476820**

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